

# Thermally assisted reversal of exchange biasing in NiO and FeMn based systems

**Citation for published version (APA):**

Heijden, van der, P. A. A., Maas, T. F. M. M., Jonge, de, W. J. M., Kools, J. C. S., Roozeboom, F., & Zaag, van der, P. J. (1998). Thermally assisted reversal of exchange biasing in NiO and FeMn based systems. *Applied Physics Letters*, 72(4), 492-494. <https://doi.org/10.1063/1.120795>

**DOI:**

[10.1063/1.120795](https://doi.org/10.1063/1.120795)

**Document status and date:**

Published: 01/01/1998

**Document Version:**

Publisher's PDF, also known as Version of Record (includes final page, issue and volume numbers)

**Please check the document version of this publication:**

- A submitted manuscript is the version of the article upon submission and before peer-review. There can be important differences between the submitted version and the official published version of record. People interested in the research are advised to contact the author for the final version of the publication, or visit the DOI to the publisher's website.
- The final author version and the galley proof are versions of the publication after peer review.
- The final published version features the final layout of the paper including the volume, issue and page numbers.

[Link to publication](#)

**General rights**

Copyright and moral rights for the publications made accessible in the public portal are retained by the authors and/or other copyright owners and it is a condition of accessing publications that users recognise and abide by the legal requirements associated with these rights.

- Users may download and print one copy of any publication from the public portal for the purpose of private study or research.
- You may not further distribute the material or use it for any profit-making activity or commercial gain
- You may freely distribute the URL identifying the publication in the public portal.

If the publication is distributed under the terms of Article 25fa of the Dutch Copyright Act, indicated by the "Taverne" license above, please follow below link for the End User Agreement:

[www.tue.nl/taverne](http://www.tue.nl/taverne)

**Take down policy**

If you believe that this document breaches copyright please contact us at:

[openaccess@tue.nl](mailto:openaccess@tue.nl)

providing details and we will investigate your claim.

# Thermally assisted reversal of exchange biasing in NiO and FeMn based systems

P. A. A. van der Heijden,<sup>a)</sup> T. F. M. M. Maas, and W. J. M. de Jonge  
*Department of Physics, Interuniversity Research Institute COBRA, Eindhoven University of Technology (EUT), 5600 MB Eindhoven, The Netherlands*

J. C. S. Kools,<sup>b)</sup> F. Roozeboom, and P. J. van der Zaag  
*Philips Research Laboratories, Prof. Holstlaan 4, 5656 AA Eindhoven, The Netherlands*

(Received 10 November 1997; accepted for publication 24 November 1997)

The stability of the exchange bias field  $H_{eb}$  has been studied for magnetron sputtered NiO/Ni<sub>66</sub>Co<sub>18</sub>Fe<sub>16</sub> and Ni<sub>66</sub>Co<sub>18</sub>Fe<sub>16</sub>/FeMn bilayers. A forced antiparallel alignment of the ferromagnetic magnetization to  $H_{eb}$  results in a gradual decrease of  $H_{eb}$  as a function of time for NiO as well as FeMn based samples. The observed decrease of  $H_{eb}$  increases with temperature and is interpreted as a thermally assisted reversal of magnetic domains in the antiferromagnetic layer.  
© 1998 American Institute of Physics. [S0003-6951(98)02204-9]

Direct exchange coupling at the interface between a ferromagnetic (F) layer and an antiferromagnetic (AF) layer may result in exchange biasing,<sup>1</sup> i.e., in a shift of the hysteresis loop of the F layer along the field axis characterized by an exchange bias field  $H_{eb}$ . Exchange biasing is used in device structures for magnetic domain stabilization in magnetoresistive sensors<sup>2</sup> as well as for pinning an F layer in magnetoresistive spin valves<sup>3</sup>.

For device applications the long term stability of  $H_{eb}$  is an important issue. The effect of temperature on the magnitude of exchange biasing has been studied extensively. Generally  $H_{eb}$  decreases with temperature and becomes zero at a temperature called the blocking temperature,  $T_B$ .<sup>4,5</sup> However, studies of time effects, i.e., the stability of  $H_{eb}$  at a given (operating) temperature and magnetic field have not been reported. Recent calculations have shown that, due to demagnetization effects, the magnetization direction of the pinned F layer of a microstructured GMR spin valve is tilted at the edges.<sup>6</sup> These spin valves are operating at elevated temperatures (approximately 100 °C) due to heating by the sense current. Therefore, the stability of the exchange biasing under these conditions is an important issue with respect to long term stability of GMR read heads.

In this letter, we will report on the stability of  $H_{eb}$  at constant temperature for an anti-parallel alignment of the magnetization of the F layer with respect to the direction of  $H_{eb}$  using NiO and FeMn AF layers, which are frequently used in biasing structures. We will show that a gradual but sizable reduction and even a reversal of  $H_{eb}$  may result. The results can be understood by a macroscopic two-level model in which the anisotropy of the AF layer and the grain size distribution play an important role.

Samples with structure Si (100)/60 nm NiO/5 nm Ni<sub>66</sub>Co<sub>18</sub>Fe<sub>16</sub>/5 nm Ta and (borosilicate) glass/3 nm Ta/5 nm Ni<sub>66</sub>Co<sub>18</sub>Fe<sub>16</sub>/10 nm FeMn/5 nm Ta were grown at room temperature in an applied field of 10–15 kA/m by a multi-source sputter apparatus. The metallic layers were deposited

by dc magnetron sputtering at a pressure of 5 mTorr Ar and the NiO layers were deposited by rf magnetron sputtering from a NiO target in an Ar pressure of 1 mTorr. After deposition, the NiO based samples were annealed up to 500 K after which the samples were field cooled down to room temperature in about 10 h in order to improve the exchange biasing.

A variable temperature magneto-optical Kerr effect apparatus was used for magnetic characterization of the samples.  $H_{eb}$  was determined as a function of time in the situation of a forced antiparallel alignment of the magnetization of the F layer and  $H_{eb}$ . To this end the sample is heated from room temperature to the desired temperature with an external field applied parallel to  $H_{eb}$ . Subsequently, the applied field of about 45 kA/m and thereby the magnetization direction of the F layer is reversed and  $H_{eb}$  is measured as a function of time at constant temperature. Note that  $H_{eb}$  is obtained from an hysteresis loop measurement during which the applied field (and the magnetization direction of the F layer) is varied. This implies that relaxation contributions to  $H_{eb}$  faster than half the hysteresis loop measurement time of 12 s cannot be observed.

The temperature dependence of the initial  $H_{eb}$  is shown in Fig. 1 for the samples with 60 nm NiO and 10 nm FeMn,

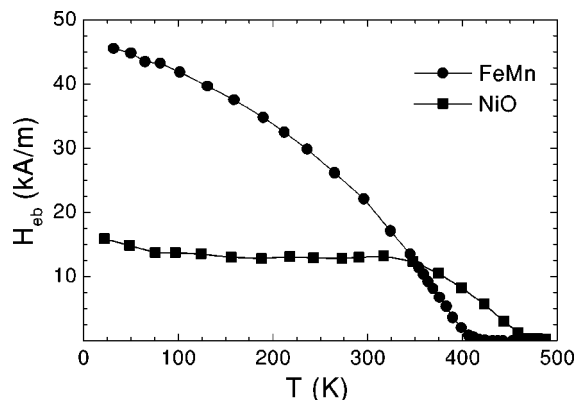


FIG. 1. The temperature dependence of the exchange bias field  $H_{eb}$  for Si (100)/60 nm NiO/5 nm Ni<sub>66</sub>Co<sub>18</sub>Fe<sub>16</sub>/5 nm Ta (squares) and glass/3 nm Ta/5 nm Ni<sub>66</sub>Co<sub>18</sub>Fe<sub>16</sub>/10 nm FeMn/5 nm Ta (circles).

<sup>a)</sup>Electronic mail: heijdenp@natlab.research.philips.com

<sup>b)</sup>Present address: CVC Products, 3100 Laurelview Court (Bldg. H), Fremont, CA 94538.

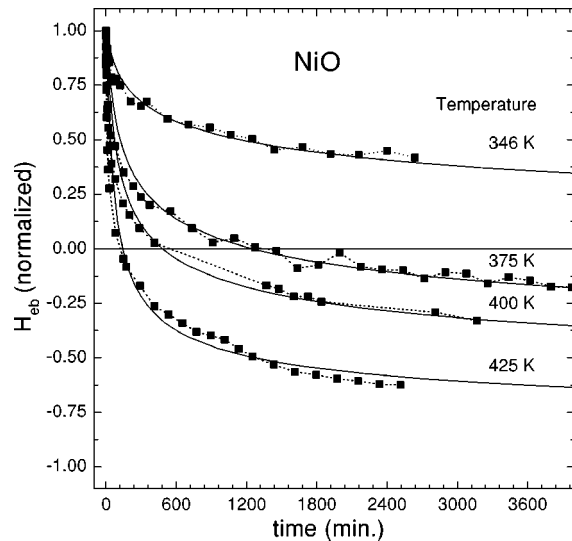


FIG. 2. The time dependence of the exchange bias field  $H_{eb}$  during a forced antiparallel alignment of the magnetization direction of the F layer and  $H_{eb}$  at several temperatures for Si (100)/60 nm NiO/5 nm  $\text{Ni}_{66}\text{Co}_{18}\text{Fe}_{16}$ /5 nm Ta. The solid lines represent the fit of the data at different temperatures as described in the text.

which is obtained by measuring hysteresis loops at increasing temperatures after cooling the sample from room temperature to 20 K in about 2 h with an external field applied parallel to  $H_{eb}$ . The figure shows that  $H_{eb}$  becomes zero at  $T_B$  of 480 K and 425 K for the NiO and FeMn based samples, respectively. The observed temperature dependence of  $H_{eb}$  is similar to that reported by others.<sup>4,5</sup>

Figure 2 shows the normalized exchange bias fields as function of time,  $t$ , for several temperatures during a forced antiparallel alignment of the magnetization of the F layer and  $H_{eb}$  for a NiO based sample. The exchange bias fields are normalized to the initial value of  $H_{eb}$  at  $t = 0$  shown in Fig. 1. Figure 2 shows that at 400 K (well below  $T_B$ )  $H_{eb}$  becomes zero after 8 h and then  $H_{eb}$  changes sign and becomes negative. This decrease of  $H_{eb}$  increases with temperature. The solid lines shown in Fig. 2 represent fits which are discussed later.

Further experiments<sup>7</sup> using a 40 nm instead of a 60 nm NiO layer show an identical decrease of  $H_{eb}$  as a function of time for several temperatures. The decrease of  $H_{eb}$  is a reversible magnetic process, i.e., reversing the external applied field and thereby the magnetization direction of the F layer during an experiment, thus restoring the original biasing configuration, resulting in an increase of  $H_{eb}$ . Experiments using different magnitudes of the applied field show that the decrease of  $H_{eb}$  is only observed if the applied field is sufficiently large to reverse the magnetization of the F layer, but is independent of the magnitude of the applied field once the magnetization is reversed. This implies that the observed decrease of  $H_{eb}$  is only induced by the forced reversal of the F layer magnetization due to the resulting frustration of the exchange coupling at the F/AF interface and is independent of the influence of the (small) external applied field on the AF layer.

Figure 3 shows that the decrease of  $H_{eb}$  as a function of time is also observed for a FeMn based sample. For temperatures close to  $T_B$ , the observed decrease of  $H_{eb}$  is similar to

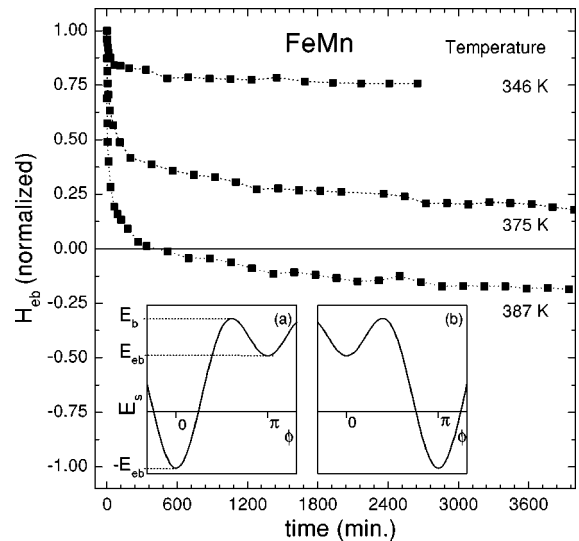


FIG. 3. The exchange bias field  $H_{eb}$  as function of time during a forced antiparallel alignment of the magnetization direction of the F layer and  $H_{eb}$  at several temperatures for glass/3 nm Ta/5 nm  $\text{Ni}_{66}\text{Co}_{18}\text{Fe}_{16}$ /10 nm FeMn/5 nm Ta. The insets show a schematic representation of the angular ( $\phi$ ) dependence of the energy per unit area,  $E_s$  of an AF layer with uniaxial anisotropy and exchange coupled to a F layer with the magnetization directed along 0 (a) and  $\pi$  (b).

that of the NiO based samples, but at lower temperatures the decrease of  $H_{eb}$  compared to that of NiO based samples is somewhat less pronounced.

The decrease of  $H_{eb}$  as a function of time can be understood by a macroscopic two-level relaxation model. Modeling the F and AF layers as magnetic monodomains and assuming an exchange coupled F/AF bilayer with uniaxial positive anisotropies,  $K_F$  and  $K_{AF}$  for the F and AF layer, respectively, and their easy axes parallel to an external applied field, the energy per unit area is given by

$$E = K_F t_F \sin^2 \theta + K_{AF} t_{AF} \sin^2 \phi - H \mu_0 M_s t_F \cos \theta + E_{eb} \cos(\theta - \phi), \quad (1)$$

in which  $t_F$  and  $t_{AF}$  are the thicknesses of the F and AF layer, respectively. The exchange bias coupling energy per unit area is given by  $E_{eb}$ . The angle between a positive applied field and the (sublattice) magnetizations of the F layer and AF layer ( $M_s$  and  $M_{sa}$ , respectively) is given by  $\theta$  and  $\phi$ , respectively. Since the field is applied along the easy magnetization axes,  $\theta$  is assumed to be either 0 or  $\pi$ . If  $K_{AF} t_{AF} > E_{eb}/2$ , then an energy barrier appears in the dependence of the energy as function of the sublattice (staggered) magnetization direction of the AF layer [see the insets of Fig. 3 for  $\theta=0$  (a) and  $\theta=\pi$  (b)]. The inset (a) of Fig. 3 refers to  $t < 0$  for which  $\phi$  is assumed to be 0 (the absolute energy minimum) and exchange biasing is observed if the staggered magnetization direction of the AF layer remains fixed during an hysteresis loop measurement. Reversing  $M_s$  at  $t=0$  results in a change of the angular dependence of the AF energy from inset (a) to (b). The energy state of the AF layer can relax towards a lower energy minimum by reversing  $M_{sa}$  (from  $\phi=0$  to  $\pi$ ), which results in a reversal of the exchange bias field.

This simplified model, assuming a single monodomain in the AF layer would result in an abrupt reversal of  $H_{eb}$

instead of the experimentally observed gradual decrease of  $H_{eb}$ . In reality, however, the AF layer has to be modeled as an ensemble of noninteracting AF domains as described by Fulcomer and Charap.<sup>8</sup> At  $t=0$ , the  $M_{sa}$  directions of the AF-domains are assumed to be distributed over  $\phi=0$  and  $\pi$  according to the Boltzmann distribution function. The reversal of  $M_s$  at  $t=0$  results in a gradual change of the distribution in  $M_{sa}$  direction towards the new equilibrium distribution (the distribution at  $t=0$  inverted) by a thermally assisted relaxation process. The time dependence of  $H_{eb}$  is given by:<sup>8</sup>  $\exp(-t/\tau)$  with  $1/\tau = \nu_0 \{ \exp[-(E_b - E_{eb})A/k_B T] + \exp[-(E_b + E_{eb})A/k_B T] \}$  in which  $\nu_0$  is the characteristic frequency for magnetic domain reversal,  $A$  is the area of the AF domain, and  $E_b$  is the barrier energy per unit area given by  $E_b = K_{AF} t_{AF} [1 + (E_{eb}/2K_{AF} t_{AF})^2]$  in the model described by Eq. (1). Analyses of the experimentally observed time dependence of  $H_{eb}$  clearly shows that it cannot be described by one single exponential function. This indicates that we are dealing with an ensemble of nonidentical AF domains with a resulting distribution of  $\tau$ .

The  $\tau$  distribution can result from a distribution in  $A$ , e.g., by a grain size distribution in the AF layer and assuming that an AF-domain coincides with an AF grain.<sup>9</sup> Transmission electron and scanning electron microscopy experiments on the NiO layer show a columnar growth with a distribution in grain sizes. Assuming a log normal grain size distribution,<sup>10</sup> the distribution in the diameter,  $d$ , of the grains is given by:  $(1/\sqrt{2\pi}\sigma) \times \exp[-\ln^2(d/d_{mean})/2\sigma^2]$ , in which  $\sigma$  and  $d_{mean}$  are 0.57 and 5 nm, respectively, as estimated from scanning electron microscope (SEM) images. The resulting fits are shown in Fig. 2 by the solid lines. In these fits the initial distribution of  $M_{sa}$  over  $\phi=0$  and  $\pi$  is assumed to be grain size independent, and  $E_{eb}$  is calculated using the data of Fig. 1. To fit the data at different temperatures, a temperature independent value for  $\nu_0$  of  $0.025 \text{ min}^{-1}$  and decreasing values for  $E_b$  (via  $K_{AF}$ ) with temperature are used. This implies that the increase in relaxation rate with temperature as observed in Fig. 2 is not only due to the increase of thermal energy but also due to the decrease of  $K_{AF}$ . The fit values obtained for  $K_{AF}$  are 11.7, 6.5, 5.2, and  $3.4 \text{ kJ/m}^3$  at 346, 375, 400, and 425 K, respectively. These values are rather low compared to the bulk values for  $K_1$ , which decrease from 500 to  $380 \text{ kJ/m}^3$  for increasing temperatures of 0–430 K.<sup>11</sup> Theoretically,  $K_{AF}$  is proportional to the square of the staggered magnetization.<sup>11</sup> A possible explanation for the low fit values of  $K_{AF}$  may be found in the fact that the staggered magnetization of the NiO layer is reduced due to finite size effects. This would give rise to a reduced value for  $K_{AF}$  and also a distribution of  $K_{AF}$ , which

is not taken into account in the fits. Note that in the modeling described above, the relaxation of  $H_{eb}$  is assumed to arise from a uniform magnetization rotation of an AF domain, while in more recent models of exchange biasing the formation of domain walls in the AF layer plays an important role.<sup>12–14</sup> However, the detailed nature of the exchange biasing mechanism is not important for the interpretation of the data in terms of a macroscopic two-level relaxation model.

We have shown that the forced reversal of the magnetization of the F layer in an exchange biased F/AF system can lead to a significant decrease of the exchange bias field,  $H_{eb}$ . In the case of a continuous misalignment this can even lead to a reversal of  $H_{eb}$  as monitored in the present study for a  $\text{Ni}_{66}\text{Co}_{18}\text{Fe}_{16}$  F layer exchange coupled to a NiO AF layer. The observed decrease of  $H_{eb}$  can be interpreted as a thermally assisted reversal of the staggered magnetization directions of magnetic domains in the AF layer. A distribution of laterally decoupled AF domains is needed to describe the decrease of  $H_{eb}$  as a function of time. These results suggest that a nonparallel alignment of the magnetization of the pinned F layer and  $H_{eb}$  has important consequences for the stability of  $H_{eb}$  and should be considered when selecting antiferromagnetic biasing materials for GMR read heads.

Part of this work was supported by the Dutch Technology Foundation (STW) and the EU-ESPRIT project on Novel Magnetic Nanodevices of artificially layered Materials (NM)<sup>2</sup>.

- <sup>1</sup>W. H. Meiklejohn and C. P. Bean, Phys. Rev. **102**, 1413 (1956); **105**, 904 (1957).
- <sup>2</sup>R. D. Hempstead, S. Krongelb, and D. A. Thompson, IEEE Trans. Magn. **MAG-14**, 521 (1978).
- <sup>3</sup>B. Dieny, V. S. Speriosu, S. S. P. Parkin, B. A. Gurney, D. R. Wilhoit, and D. Mauri, Phys. Rev. B **43**, 1297 (1991).
- <sup>4</sup>V. S. Speriosu, D. A. Herman, Jr., I. L. Sanders, and T. Yogi, IBM J. Res. Dev. **34**, 884 (1990).
- <sup>5</sup>S. Soeya, T. Imagawa, K. Mitsuoka, and S. Narishige, J. Appl. Phys. **76**, 5356 (1994).
- <sup>6</sup>K. Nakamoto, Y. Kawato, Y. Suzuki, Y. Hamakawa, T. Kawabe, K. Fujimoto, M. Fuyama, and Y. Sugita, IEEE Trans. Magn. **MAG-32**, 3374 (1996).
- <sup>7</sup>P. A. A. van der Heijden, T. F. M. M. Maas, J. C. S. Kools, F. Roozeboom, P. J. van der Zaag, and W. J. M. de Jonge, J. Appl. Phys. (special issue on 7th Joint MMM/Intermag. Conference) (to be published).
- <sup>8</sup>E. Fulcomer and S. H. Charap, J. Appl. Phys. **43**, 4190 (1972).
- <sup>9</sup>K. Nishioka, C. Hou, H. Fujiwara, and R. D. Metzger, J. Appl. Phys. **80**, 4528 (1996).
- <sup>10</sup>K. Barmak, R. A. Ristau, K. R. Coffey, M. A. Parker, and J. K. Howard, J. Appl. Phys. **79**, 5330 (1996).
- <sup>11</sup>H. Kondoh, J. Phys. Soc. Jpn. **15**, 1970 (1960).
- <sup>12</sup>D. Mauri, H. C. Siegmann, P. S. Bagus, and E. Kay, J. Appl. Phys. **62**, 3047 (1987).
- <sup>13</sup>A. P. Malozemoff, J. Appl. Phys. **63**, 3874 (1988).
- <sup>14</sup>N. C. Koon, Phys. Rev. Lett. **78**, 4865 (1997).